SURFSCAN 6200 SOP for 4-Inch Wafers

Important Guidelines

- Wafer Thickness: Do not use wafers thicker than 1 mm.
- Log all scans and issues in the logbook.
- Always log off after completing your session.

Procedure

1. Login Instructions

- Use the password: fab (new password)
- If the keyboard isn't working, use the virtual keyboard on the monitor.
- Double-click the SCAN icon.

3. Loading a Recipe

- 1. Click Recipe > Load.
- 2. Select a standard recipe for 4-inch wafers:
 - O UCSB GAIN4 0.16-1.6 (for 0.16-1.6 μm).
 - **O UCSB GAIN2 1.6-28 (for 1.6-28 μm).**
- 3. Click OK. The recipe name will appear at the top.

4. Modify Recipe

- 1. Select Recipe > Save as, and rename it (e.g., your name or company name).
- 2. Go to Recipe/View/Modify to adjust parameters:
 - Wafer diameter, edge exclusion, gain, threshold, indexer, etc.
- 3. Under Bin Split, click Default Bin to apply changes.
- 4. Save the modifications.

5. Load Wafers into the Cassette

- 1. Use the white cassette for 4-inch wafers (right indexer).
- 2. Load wafers face up, with the major flat away from you.
- 3. Place the cassette properly in the right indexer.

6. Start Scanning

- 1. On the monitor, select CASS (Cassette) and wait for the tool to detect wafers.
- 2. Choose one of the following:
 - Single Wafer: Select the wafer and click START (upper bar).
 - Multiple Wafers: Select AUTO, then click START.
- 3. Record the scan results.

7. Completion

- 1. Once scanning is complete:
 - Press ENTER on the small laptop to save the scan as a photo:
 - Location: Desktop/Local Disk(C)/Users/Public/Public Documentation.
 - Photos can be accessed/downloaded via the Nanofab server.
 - Note: Full data-saving functionality will be available in January 2025.
- 2. Click HOME, then select RECIPE/Exit, and log off.

8. Log Book

• Record details of your scan and any issues in the Log Book.